

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Hidema Tanaka, et al.

Serial No.: 10/762,654

Filed: January 21, 2005

For: CIPHER STRENGTH EVALUATION  
APPARATUS

Examiner: Kim, Jung W.

Group Art Unit: 2132

May 8, 2008

Costa Mesa, California 92626

**RESPONSE TO OFFICE ACTION**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action of February 5, 2008, please amend the above-identified application as follows: